

VIA EFS
Docket No.: 199372003910
(PATENT)
Client reference: 146630US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Divisional Patent Application of:

Naoki SHINDO et al.

Confirmation No.: 2798

Application No.: 10/779,397

Examiner: Alexander Markoff

Filed: February 13, 2004

Art Unit: 1792

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated April 7, 2008, for which a response was due on July 7, 2008, and for which a three-month extension of time is requested to extend the time for response from July 7, 2008 to October 7, 2008, please amend the above-identified patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

A Request for Continued Examination (RCE) is also submitted herewith.